

<b>Notice of References Cited</b>	Application/Control No. 10/026,614	Applicant(s)/Patent Under Reexamination NAITO ET AL.	
	Examiner Linda Wong	Art Unit 2611	Page 1 of 1

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*	B	US-6,912,250	06-2005	Adireddy et al.	375/232
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	K	US-			
	L	US-			
	M	US-			

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**NON-PATENT DOCUMENTS**

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